

#### Discrete Tomography in Materials Science



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### **Overview**

- Introduction to tomography
- Electron tomography
- Discrete electron tomography
- Outlook



#### **Electron microscopy**







#### **Electron tomography**





Sara Bals, K. Joost Batenburg, Duoduo Liang, Oleg Lebedev, Gustaaf Van Tendeloo, Alexander Aerts, Johan A. Martens, and Christine E. A. Kirschhock, J. Am. Chem. Soc., 131(13), 4769, 2009



# Tomography: principle



$$N_d = N_{in} e^{-\int_{\text{ray}} f(x,y) \, \mathrm{d}s}$$

$$\int_{\text{ray}} f(x, y) \, \mathrm{d}s = \log \frac{N_{in}}{N_d}$$



# **Tomography at all scales**

- Medical tomography (CT) is by far the most common subfield of tomography research
- Tomography is also being used outside of CT, at all imaginable scales, from light years down to sub-nm
- Electron tomography covers the smallest of these scales



## Tomography at all scales: astrotomography



Light year



## Tomography at all scales: seismic tomography









## Tomography at all scales: Electron tomography



STEM image of LZO, Ellen Biermans





## **Electron tomography:** Key limitations

- Tomography requires a large number of projection angles
  - Beam damage
  - Time consuming
- ... sampled at regular intervals
  - Full angular range is needed



## **Few projections**



Original image Filtered backprojection, 5 projections



# Electron tomography: Tomography holder







Fischione



## **Missing wedge**





-45° - +45°



-60° - +60° -75° - +75°



-90° - +90°



#### Insufficient number of projections

Limited angular range







K.J. Batenburg, S. Bals et al., *Ultramicroscopy, 109(6), 730-740, 2009* 



## Electron Tomography: Tomography holder





HAADF STEM image of a Ni specimen containing alumina particles. The needleshape was created using an FEI DB 235 DualBeam Instrument equipped with an Omniprobe nanomanipulator for specimen lift-out.



**Reconstruction of alumina particles.** An FEI Tecnai F30 TEM was used to collect 19 x-ray spectral images, 500 x 100 pixels by 1024 channels at a rate of 50msec/pixel. The specimen was rotated on-axis in 10° increments from -90° to +90°. Total data acquisition was approximately one million x-ray spectra taken in the course of 4 days. Analysis was conducted simultaneously with the Sandia multivariate statistical analysis software. In the image, Ni is shown as red and the alumina component is shown after image alignment in green.

Images couriesy of P. Kotula, Sandia National Laboratories, U.S.A., L.A. Giannuzzi, FEI Company, U.S.A., and F. de Haas, FEI Company, The Netherlands.



# **Discrete tomography**

- Fixed set of possible intensities (grey values)
- Materials should be known in advance
- Use prior knowledge about the materials in the reconstruction



C. Kübel, FEI



DiamCAD NV



Skyscan NV



**Algorithm: DART** 

#### DART: Discrete Algebraic Reconstruction Technique

- Iterative method
- Input: projection images + set of intensities
- Output: segmented image











Simulation image

SIRT reconstruction

SIRT reconstruction, thresholded

13 projections-60/+60 degrees

K.J. Batenburg, S. Bals et al., Ultramicroscopy, 109(6), 730-740, 2009





Intermediate reconstruction



Final reconstruction (3 iterations)



Original image







Original image

Discrete tomography, 5 projections



#### Example:

#### electron tomography of a nanoparticle

#### HAADF STEM imaging, FEI Titan microscope





#### **Example:** electron tomography of a nanoparticle

#### HAADF STEM tomography, FEI Titan



Classical reconstruction, using the SIRT algorithm

**DART** reconstruction

S. Bals, K.J. Batenburg et al., Nano Letters 7(12), 3669-3674 (2007) K.J. Batenburg, S. Bals et al., Ultramicroscopy 109(6), 730-740 (2009)





S. Bals, K.J. Batenburg et al., *Nano Letters, 7*(12), 3669-3674, 2007

S. Turner, S.M.F. Tavernier et al., J. Nanoparticle Research, 12(2), 615-622, 2009

S. Bals, K.J. Batenburg et al., J. Am. Chem. Soc., 131(13), 4769-4773, 2009

 By exploiting prior knowledge, more accurate reconstructions can be computed from *the same* measured data.





# Supercomputing for tomography



- FASTRA II: 12 TFLOPS supercomputer on your desk
- 13 NVIDIA GPUs
- http://fastra2.ua.ac.be





- For effective nanometrology, the 3<sup>rd</sup> dimension is crucial
- Electron tomography is a versatile tool for 3D nanometrology
- New instruments and computational models can overcome traditional limitations
- Discrete tomography allows accurate imaging at the nanoscale, up to the atomic level





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